Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/632,499	OLSCHEWSKI, FRANK	
Examiner	Art Unit	
Dennis Rosario	2624	

SEARCHED .				
Class	Subclass	Date	Examiner	
382	107	114107	DL	
	(103)	(2/1/07)	(0K)	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES				
(INCLUDING SEARCH STRATEGY)				
(updated)	DATE	EXMR		
(vpdated) (Fast, all dB)	1/4)107 7/21/07)	DR (DP)		
IEEE-trajectory (near) pixel and filter#-	115102	DR		
TEEE-optical Knew/flow and pixel and Ctraged or Frack*)-	64 891/02	DR		
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